

<b>Notice of References Cited</b>	Application/Control No. 10/604,643	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,469,673	10-2002	Kaiponen, Teemu	343/703
	B	US-6,720,935	04-2004	Lamensdorf et al.	343/895
	C	US-5,521,606	05-1996	Iijima et al.	343/713
	D	US-5,734,350	03-1998	Deming et al.	343/700MS
	E	US-5,767,810	06-1998	Hagiwara et al.	343/700MS
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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